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# Correlation between thermal contact resistance and filling behavior of a polymer melt into multiscale cavities in injection molding



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#### ABSTRACT

The mechanism through which thermal contact resistance (TCR) is generated and how it changes at the interface between a polymer melt and mold wall during injection molding have not yet been clearly identified. In particular, despite the TCR significantly influencing the surface quality of the resulting part, few studies have reported on the injection molding of a part with microstructural features. In this study, we predict the TCR using a new approach. Through a molding process known as "short shot", we indirectly measured the filling height of patterns as a function of time. In addition, to make these results consistent with filling analysis results, we calculated the TCR through recursive calculations. With this approach, not only changes in the TCR as a function of time but also changes by position were estimated. Furthermore, on the basis of the TCR determined in this manner, the filling behavior of micropatterns according to the change in TCR was examined. Finally, this study shows that artificial control of the roughness of a mold surface leads to control of the TCR, resulting in improved transcription of micropatterns.

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#### 1. Introduction

Thermal contact resistance (TCR) between solids has been continuously studied for the past 50 years. Surface roughness and contact pressure on the surface of contacts are factors that most strongly influence TCR. Theoretical models of TCR have also been developed [1]. In contrast, a generalized theoretical model for the TCR between a fluid and a solid—in particular, the TCR between a polymer melt and a mold used in injection molding—has not yet been established. Yu et al. [2] published the first report on TCR in this regard in 1990. Using experiments and numerical analysis, they predicted that the TCR changes depending on the injection molding conditions and time. Delaunay et al. [3] used experiments and measurements to demonstrate that during the injection molding process, the greatest change in TCR occurs when the polymer used to fill cavities shrinks and separates from the mold during the packing stage.

In contrast to the packing stage, the injection stage before packing is very short; thus, the heat flux and temperature at the interface are difficult to measure. In addition, macroscale changes are very slight; therefore, studies of TCR at this stage are rare. Nonetheless, nano/microscale structural studies of injection molding have been conducted; these studies have revealed that the influence of minute temperature changes at this interface on surface quality cannot be ignored [4].

In this study, we predict changes in the TCR according to time and position during the injection molding process (injection stage and packing stage) through experiments and numerical analyses. In particular, we investigate changes in the TCR that occur at the moment when the polymer melt contacts the mold surface and those that occur a short time thereafter. At this point, the injection molding object is a thin, rectangular plastic plate at the macroscale; at the microscale, the object's surface exhibits repeated microscale patterns. These patterns exist between the mold surface and the polymer melt; therefore, their filling behavior is directly affected by the degree of heat transfer at this interface. Thus, these patterns are expected to serve as another measure of TCR.

In polymer injection molding analysis, simulating the region where macroscale and microscale cavities coexist is difficult. Modeling and processing these cavities in a single domain is a problem that requires large memory capacity and unrealistic calculation times, which is inefficient. Thus, numerous attempts to solve this problem have been reported in the literature. Addressing this problem for the first time in 1990, Yoshii and Kuramoto [5] used a vitrified layer bending deformation model

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### Nomenclature

4	material constant 1
$A_1$	material constant 2 (V)
A2	indicidit Constant 2 (K) gross sectional area of microscale inlet $(m^2)$
A <sub>mi</sub> b	closs-sectional area of finicioscale finiti (in )
D <sub>s</sub>	average value of the factors of the circular base ( $\mu$ iii) specific best conscitu ( $I/kg K$ )
	specific field capacity (J/Kg K)
$D_1$	diameter of cooling channel (m)
$D_{cc}$	thermal offusivity $(I/m^2 K e^{0.5})$
e E	curface tension force acting at the air/polymor molt
r <sub>st</sub>	interface (N)
σ	gravity vector $(m/s^2)$
5 h	contact heat transfer coefficient $(W/m^2 K)$
h	solid contact conductance $(W/m^2 K)$
п <sub>с</sub> Н	surface microhardness of stamper (Pa)
h	contact heat transfer coefficient between cooling water
nc=c	and core $(W/m^2 K)$
h <sub>a</sub>	gas filled gap conductance $(W/m^2 K)$
h.,	contact heat transfer coefficient between polymer and
··p-s	stamper ( $W/m^2 K$ )
h <sub>c</sub>	contact heat transfer coefficient between stamper and
···s=c	core $(W/m^2 K)$
kair	thermal conductivity of air (W/m K)
kcore	thermal conductivity of core (W/m K)
k <sub>cw</sub>	thermal conductivity of cooling water (W/m K)
k <sub>nm</sub>	thermal conductivity of polymer melt (W/m K)
$k_{nm}$	thermal conductivity of polymer (W/m K)
$k_{p-s}$	harmonic mean thermal conductivity of the interface
1	polymer melt and stamper (W/m K)
k <sub>s</sub>	thermal conductivity of stamper (W/m K)
$k_{s-c}$	harmonic mean thermal conductivity of the interface
	stamper and core (W/m K)
14	
IVI	gas parameter
м ṁ	gas parameter rate of mass flow (kg/s)
м ṁ m	gas parameter rate of mass flow (kg/s) asperity slope on the front of stamper
M ṁ m m <sub>core</sub>	gas parameter rate of mass flow (kg/s) asperity slope on the front of stamper asperity slope on the core
M ṁ m m <sub>core</sub> m <sub>e</sub>	gas parameter rate of mass flow (kg/s) asperity slope on the front of stamper asperity slope on the core effective mean absolute asperity slope of the interface
M ṁ m m <sub>core</sub> m <sub>e</sub> m <sub>s</sub>	gas parameter rate of mass flow (kg/s) asperity slope on the front of stamper asperity slope on the core effective mean absolute asperity slope of the interface asperity slope on the back of stamper
M m m <sub>core</sub> m <sub>e</sub> m <sub>s</sub> n	gas parameter rate of mass flow (kg/s) asperity slope on the front of stamper asperity slope on the core effective mean absolute asperity slope of the interface asperity slope on the back of stamper power law index in the high shear rate regime
M m m <sub>core</sub> m <sub>e</sub> m <sub>s</sub> n p p	gas parameter rate of mass flow (kg/s) asperity slope on the front of stamper asperity slope on the core effective mean absolute asperity slope of the interface asperity slope on the back of stamper power law index in the high shear rate regime pressure (Pa)
M $\dot{m}$ $m_{core}$ $m_e$ $m_s$ n p $P(\zeta)$ P	gas parameter rate of mass flow (kg/s) asperity slope on the front of stamper asperity slope on the core effective mean absolute asperity slope of the interface asperity slope on the back of stamper power law index in the high shear rate regime pressure (Pa) pressure due to the surface tension of melt (Pa) atmospheric processor (Pa)
M $\dot{m}$ $m_{core}$ $m_e$ $m_s$ n p $P(\zeta)$ $P_0$ P	gas parameter rate of mass flow (kg/s) asperity slope on the front of stamper asperity slope on the core effective mean absolute asperity slope of the interface asperity slope on the back of stamper power law index in the high shear rate regime pressure (Pa) pressure due to the surface tension of melt (Pa) atmospheric pressure (Pa) pressure in the melt vicinity of the rough surface (Pa)
$M$ $m$ $m_{core}$ $m_e$ $m_s$ $n$ $P$ $P(\zeta)$ $P_0$ $P_1$ $n$	gas parameter rate of mass flow (kg/s) asperity slope on the front of stamper asperity slope on the core effective mean absolute asperity slope of the interface asperity slope on the back of stamper power law index in the high shear rate regime pressure (Pa) pressure due to the surface tension of melt (Pa) atmospheric pressure (Pa) pressure in the melt vicinity of the rough surface (Pa) contact pressure (Pa)
$M$ $m$ $m_{core}$ $m_e$ $m_s$ $n$ $P(\zeta)$ $P_0$ $P_1$ $p_c$ $Pr$	gas parameter rate of mass flow (kg/s) asperity slope on the front of stamper asperity slope on the core effective mean absolute asperity slope of the interface asperity slope on the back of stamper power law index in the high shear rate regime pressure (Pa) pressure due to the surface tension of melt (Pa) atmospheric pressure (Pa) pressure in the melt vicinity of the rough surface (Pa) contact pressure (Pa) Prandtl number
$M$ $m$ $m_{core}$ $m_{e}$ $m_{s}$ $n$ $P(\zeta)$ $P_{0}$ $P_{1}$ $P_{c}$ $Pr$ $O$	gas parameter rate of mass flow (kg/s) asperity slope on the front of stamper asperity slope on the core effective mean absolute asperity slope of the interface asperity slope on the back of stamper power law index in the high shear rate regime pressure (Pa) pressure due to the surface tension of melt (Pa) atmospheric pressure (Pa) pressure in the melt vicinity of the rough surface (Pa) contact pressure (Pa) Prandtl number heat source (I)
$M$ $m$ $m_{core}$ $m_{e}$ $m_{s}$ $n$ $P(\zeta)$ $P_{0}$ $P_{1}$ $P_{c}$ $Pr$ $Q$ $R$	gas parameter rate of mass flow (kg/s) asperity slope on the front of stamper asperity slope on the core effective mean absolute asperity slope of the interface asperity slope on the back of stamper power law index in the high shear rate regime pressure (Pa) pressure due to the surface tension of melt (Pa) atmospheric pressure (Pa) pressure in the melt vicinity of the rough surface (Pa) contact pressure (Pa) Prandtl number heat source (J) thermal contact resistance coefficient (m <sup>2</sup> K/W)
$M$ $m$ $m_{core}$ $m_{e}$ $m_{s}$ $n$ $P(\zeta)$ $P_{0}$ $P_{1}$ $P_{c}$ $Pr$ $Q$ $R$ Re	gas parameter rate of mass flow (kg/s) asperity slope on the front of stamper asperity slope on the core effective mean absolute asperity slope of the interface asperity slope on the back of stamper power law index in the high shear rate regime pressure (Pa) pressure due to the surface tension of melt (Pa) atmospheric pressure (Pa) pressure in the melt vicinity of the rough surface (Pa) contact pressure (Pa) Prandtl number heat source (J) thermal contact resistance coefficient (m <sup>2</sup> K/W) Revnolds number
M $\dot{m}$ $m_{core}$ $m_{e}$ $m_{s}$ n p $P(\zeta)$ $P_{0}$ $P_{1}$ $p_{c}$ $P_{1}$ $p_{c}$ $P_{T}$ Q R Re	gas parameter rate of mass flow (kg/s) asperity slope on the front of stamper asperity slope on the core effective mean absolute asperity slope of the interface asperity slope on the back of stamper power law index in the high shear rate regime pressure (Pa) pressure due to the surface tension of melt (Pa) atmospheric pressure (Pa) pressure in the melt vicinity of the rough surface (Pa) contact pressure (Pa) Prandtl number heat source (J) thermal contact resistance coefficient (m <sup>2</sup> K/W) Reynolds number thermal contact resistance coefficient between polymer
$M$ $m$ $m_{core}$ $m_{e}$ $m_{s}$ $n$ $P(\zeta)$ $P_{0}$ $P_{1}$ $P_{c}$ $Pr$ $Q$ $R$ $Re$ $R_{p-c}$	gas parameter rate of mass flow (kg/s) asperity slope on the front of stamper asperity slope on the core effective mean absolute asperity slope of the interface asperity slope on the back of stamper power law index in the high shear rate regime pressure (Pa) pressure due to the surface tension of melt (Pa) atmospheric pressure (Pa) pressure in the melt vicinity of the rough surface (Pa) contact pressure (Pa) Prandtl number heat source (J) thermal contact resistance coefficient (m <sup>2</sup> K/W) Reynolds number thermal contact resistance coefficient between polymer and core (m <sup>2</sup> K/W)
M $\dot{m}$ $m_{core}$ $m_e$ $m_s$ n p $P(\zeta)$ $P_0$ $P_1$ $p_c$ $P_1$ $p_c$ $P_T$ Q R Re $R_{p-c}$ $R_{n-s}$	gas parameter rate of mass flow (kg/s) asperity slope on the front of stamper asperity slope on the core effective mean absolute asperity slope of the interface asperity slope on the back of stamper power law index in the high shear rate regime pressure (Pa) pressure due to the surface tension of melt (Pa) atmospheric pressure (Pa) pressure in the melt vicinity of the rough surface (Pa) contact pressure (Pa) Prandtl number heat source (J) thermal contact resistance coefficient (m <sup>2</sup> K/W) Reynolds number thermal contact resistance coefficient between polymer and core (m <sup>2</sup> K/W) thermal contact resistance coefficient between polymer
M $\dot{m}$ $m_{core}$ $m_e$ $m_s$ n p $P(\zeta)$ $P_0$ $P_1$ $p_c$ $P_1$ $p_c$ $P_T$ Q R Re $R_{p-c}$ $R_{p-s}$	gas parameter rate of mass flow (kg/s) asperity slope on the front of stamper asperity slope on the core effective mean absolute asperity slope of the interface asperity slope on the back of stamper power law index in the high shear rate regime pressure (Pa) pressure due to the surface tension of melt (Pa) atmospheric pressure (Pa) pressure in the melt vicinity of the rough surface (Pa) contact pressure (Pa) Prandtl number heat source (J) thermal contact resistance coefficient (m <sup>2</sup> K/W) Reynolds number thermal contact resistance coefficient between polymer and core (m <sup>2</sup> K/W) thermal contact resistance coefficient between polymer and stamper (m <sup>2</sup> K/W)
M $\dot{m}$ $m_{core}$ $m_e$ $m_s$ n p $P(\zeta)$ $P_0$ $P_1$ $p_c$ $P_1$ $p_c$ $P_T$ Q R Re $R_{p-c}$ $R_{p-s}$ $R_{s-c}$	gas parameter rate of mass flow (kg/s) asperity slope on the front of stamper asperity slope on the core effective mean absolute asperity slope of the interface asperity slope on the back of stamper power law index in the high shear rate regime pressure (Pa) pressure due to the surface tension of melt (Pa) atmospheric pressure (Pa) pressure in the melt vicinity of the rough surface (Pa) contact pressure (Pa) Prandtl number heat source (J) thermal contact resistance coefficient (m <sup>2</sup> K/W) Reynolds number thermal contact resistance coefficient between polymer and core (m <sup>2</sup> K/W) thermal contact resistance coefficient between polymer and stamper (m <sup>2</sup> K/W) thermal contact resistance coefficient between stamper
M $\dot{m}$ $m_{core}$ $m_e$ $m_s$ n p $P(\zeta)$ $P_0$ $P_1$ $p_c$ $P_T$ Q R Re $R_{p-c}$ $R_{p-s}$ $R_{s-c}$	gas parameter rate of mass flow (kg/s) asperity slope on the front of stamper asperity slope on the core effective mean absolute asperity slope of the interface asperity slope on the back of stamper power law index in the high shear rate regime pressure (Pa) pressure due to the surface tension of melt (Pa) atmospheric pressure (Pa) pressure in the melt vicinity of the rough surface (Pa) contact pressure (Pa) Prandtl number heat source (J) thermal contact resistance coefficient (m <sup>2</sup> K/W) Reynolds number thermal contact resistance coefficient between polymer and core (m <sup>2</sup> K/W) thermal contact resistance coefficient between stamper and core (m <sup>2</sup> K/W)
M $\dot{m}$ $m_{core}$ $m_e$ $m_s$ n p $P(\zeta)$ $P_0$ $P_1$ $p_c$ $P_T$ Q R Re $R_{p-c}$ $R_{p-s}$ $R_{sm}$	gas parameter rate of mass flow (kg/s) asperity slope on the front of stamper asperity slope on the core effective mean absolute asperity slope of the interface asperity slope on the back of stamper power law index in the high shear rate regime pressure (Pa) pressure due to the surface tension of melt (Pa) atmospheric pressure (Pa) pressure in the melt vicinity of the rough surface (Pa) contact pressure (Pa) Prandtl number heat source (J) thermal contact resistance coefficient (m <sup>2</sup> K/W) Reynolds number thermal contact resistance coefficient between polymer and core (m <sup>2</sup> K/W) thermal contact resistance coefficient between stamper and core (m <sup>2</sup> K/W) thermal contact resistance coefficient between stamper and core (m <sup>2</sup> K/W) mean peak spacing on the front of stamper (µm)
M $\dot{m}$ $m_{core}$ $m_e$ $m_s$ n p $P(\zeta)$ $P_0$ $P_1$ $P_c$ $P_1$ $P_c$ $P_T$ Q R Re $R_{p-c}$ $R_{p-s}$ $R_{s-c}$ $R_{sm}$ t	gas parameter rate of mass flow (kg/s) asperity slope on the front of stamper asperity slope on the core effective mean absolute asperity slope of the interface asperity slope on the back of stamper power law index in the high shear rate regime pressure (Pa) pressure due to the surface tension of melt (Pa) atmospheric pressure (Pa) pressure in the melt vicinity of the rough surface (Pa) contact pressure (Pa) Prandtl number heat source (J) thermal contact resistance coefficient (m <sup>2</sup> K/W) Reynolds number thermal contact resistance coefficient between polymer and core (m <sup>2</sup> K/W) thermal contact resistance coefficient between stamper and core (m <sup>2</sup> K/W) thermal contact resistance coefficient between stamper and core (m <sup>2</sup> K/W) mean peak spacing on the front of stamper (µm) time (s)
M $\dot{m}$ $m_{core}$ $m_e$ $m_s$ n p $P(\zeta)$ $P_0$ $P_1$ $p_c$ $P_T$ Q R Re $R_{p-c}$ $R_{s-c}$ $R_{sm}$ t T	gas parameter rate of mass flow (kg/s) asperity slope on the front of stamper asperity slope on the core effective mean absolute asperity slope of the interface asperity slope on the back of stamper power law index in the high shear rate regime pressure (Pa) pressure due to the surface tension of melt (Pa) atmospheric pressure (Pa) pressure in the melt vicinity of the rough surface (Pa) contact pressure (Pa) Prandtl number heat source (J) thermal contact resistance coefficient (m <sup>2</sup> K/W) Reynolds number thermal contact resistance coefficient between polymer and core (m <sup>2</sup> K/W) thermal contact resistance coefficient between stamper and stamper (m <sup>2</sup> K/W) thermal contact resistance coefficient between stamper and core (m <sup>2</sup> K/W) mean peak spacing on the front of stamper ( $\mu$ m) time (s) temperature (°C)
M $\dot{m}$ $m_{core}$ $m_e$ $m_s$ n p $P(\zeta)$ $P_0$ $P_1$ $p_c$ $P_1$ $p_c$ $P_T$ Q R Re $R_{p-c}$ $R_{p-s}$ $R_{s-c}$ $R_{sm}$ t T $T^*$	gas parameter rate of mass flow (kg/s) asperity slope on the front of stamper asperity slope on the core effective mean absolute asperity slope of the interface asperity slope on the back of stamper power law index in the high shear rate regime pressure (Pa) pressure due to the surface tension of melt (Pa) atmospheric pressure (Pa) pressure in the melt vicinity of the rough surface (Pa) contact pressure (Pa) Prandtl number heat source (J) thermal contact resistance coefficient (m <sup>2</sup> K/W) Reynolds number thermal contact resistance coefficient between polymer and core (m <sup>2</sup> K/W) thermal contact resistance coefficient between polymer and stamper (m <sup>2</sup> K/W) thermal contact resistance coefficient between stamper and core (m <sup>2</sup> K/W) thermal contact resistance coefficient between stamper and core (m <sup>2</sup> K/W) mean peak spacing on the front of stamper (µm) time (s) temperature (°C) glass transition temperature (°C)
M $\dot{m}$ $m_{core}$ $m_e$ $m_s$ n p $P(\zeta)$ $P_0$ $P_1$ $p_c$ $P_T$ Q R Re $R_{p-c}$ $R_{s-c}$ $R_{sm}$ t T $T^*$ $T_0$	gas parameter rate of mass flow (kg/s) asperity slope on the front of stamper asperity slope on the core effective mean absolute asperity slope of the interface asperity slope on the back of stamper power law index in the high shear rate regime pressure (Pa) pressure due to the surface tension of melt (Pa) atmospheric pressure (Pa) pressure in the melt vicinity of the rough surface (Pa) contact pressure (Pa) Prandtl number heat source (J) thermal contact resistance coefficient (m <sup>2</sup> K/W) Reynolds number thermal contact resistance coefficient between polymer and core (m <sup>2</sup> K/W) thermal contact resistance coefficient between polymer and stamper (m <sup>2</sup> K/W) thermal contact resistance coefficient between stamper and core (m <sup>2</sup> K/W) thermal contact resistance coefficient between stamper and core (m <sup>2</sup> K/W) thermal contact resistance coefficient between stamper and core (m <sup>2</sup> K/W) mean peak spacing on the front of stamper (µm) time (s) temperature (°C) glass transition temperature (°C)
$M$ $\dot{m}$ $m_{core}$ $m_{e}$ $m_{s}$ $n$ $p$ $P(\zeta)$ $P_{0}$ $P_{1}$ $p_{c}$ $P_{1}$ $p_{c}$ $P_{T}$ $Q$ $R$ $Re$ $R_{p-c}$ $R_{s-c}$ $R_{sm}$ $t$ $T$ $T^{*}$ $T_{0}$ $T_{1}$	gas parameter rate of mass flow (kg/s) asperity slope on the front of stamper asperity slope on the core effective mean absolute asperity slope of the interface asperity slope on the back of stamper power law index in the high shear rate regime pressure (Pa) pressure due to the surface tension of melt (Pa) atmospheric pressure (Pa) pressure in the melt vicinity of the rough surface (Pa) contact pressure (Pa) Prandtl number heat source (J) thermal contact resistance coefficient (m <sup>2</sup> K/W) Reynolds number thermal contact resistance coefficient between polymer and core (m <sup>2</sup> K/W) thermal contact resistance coefficient between polymer and stamper (m <sup>2</sup> K/W) thermal contact resistance coefficient between stamper and core (m <sup>2</sup> K/W) mean peak spacing on the front of stamper ( $\mu$ m) time (s) temperature (°C) glass transition temperature (°C) entrapped air temperature (°C)
M $\dot{m}$ $m_{core}$ $m_e$ $m_s$ n p $P(\zeta)$ $P_0$ $P_1$ $p_c$ $P_T$ Q R Re $R_{p-c}$ $R_{s-c}$ $R_{sm}$ t T $T_1$ $T_{core}$	gas parameter rate of mass flow (kg/s) asperity slope on the front of stamper asperity slope on the core effective mean absolute asperity slope of the interface asperity slope on the back of stamper power law index in the high shear rate regime pressure (Pa) pressure due to the surface tension of melt (Pa) atmospheric pressure (Pa) pressure in the melt vicinity of the rough surface (Pa) contact pressure (Pa) Prandtl number heat source (J) thermal contact resistance coefficient (m <sup>2</sup> K/W) Reynolds number thermal contact resistance coefficient between polymer and core (m <sup>2</sup> K/W) thermal contact resistance coefficient between polymer and stamper (m <sup>2</sup> K/W) thermal contact resistance coefficient between stamper and core (m <sup>2</sup> K/W) thermal contact resistance coefficient between stamper and core (m <sup>2</sup> K/W) mean peak spacing on the front of stamper ( $\mu$ m) time (s) temperature (°C) glass transition temperature (°C) initial air temperature (°C) entrapped air temperature (°C)
$\begin{array}{c} M\\ \dot{m}\\ \dot{m}\\ m\\ m_{core}\\ m_{e}\\ m_{s}\\ n\\ p\\ P(\zeta)\\ P_{0}\\ P_{1}\\ p_{c}\\ P_{1}\\ p_{c}\\ P_{1}\\ p_{c}\\ P_{1}\\ Q\\ R\\ Re\\ R_{p-c}\\ R_{s-c}\\ R_{s-c}\\ R_{sm}\\ t\\ T\\ T^{*}\\ T_{0}\\ T_{1}\\ T_{core}\\ TCR_{p-c}\\ \end{array}$	gas parameter rate of mass flow (kg/s) asperity slope on the front of stamper asperity slope on the core effective mean absolute asperity slope of the interface asperity slope on the back of stamper power law index in the high shear rate regime pressure (Pa) pressure due to the surface tension of melt (Pa) atmospheric pressure (Pa) pressure in the melt vicinity of the rough surface (Pa) contact pressure (Pa) Prandtl number heat source (J) thermal contact resistance coefficient (m <sup>2</sup> K/W) Reynolds number thermal contact resistance coefficient between polymer and core (m <sup>2</sup> K/W) thermal contact resistance coefficient between polymer and stamper (m <sup>2</sup> K/W) thermal contact resistance coefficient between stamper and core (m <sup>2</sup> K/W) thermal contact resistance coefficient between stamper and core (m <sup>2</sup> K/W) thermal contact resistance coefficient between stamper and core (m <sup>2</sup> K/W) mean peak spacing on the front of stamper (µm) time (s) temperature (°C) glass transition temperature (°C) initial air temperature (°C) entrapped air temperature (°C) temperature of core (°C)

$TCR_{p-s}$	thermal contact resistance between polymer and stam- per $(m^2 K/W)$
TCR <sub>s-c</sub>	thermal contact resistance between stamper and core $\frac{1}{100}$
т	$(\Pi^{-} \mathbf{K}/\mathbf{V})$
I <sub>CW</sub>	temperature of cooling water (°C)
I <sub>inj</sub> T	temperature of injected polymer melt (°C)
I <sub>mold</sub>	temperature of mold (°C)
I <sub>pm</sub>	temperature of polymer melt (°C)
$T_s$	temperature of stamper (°C)
и	fluid velocity (m/s)
$u_m$	mean velocity (m/s)
$V_{f1}$	volume fraction of fluid 1
$V_{f2}$	volume fraction of fluid 2
Y	effective gap thickness (µm)
$Y_0$	initial mean surface plane separation $(\mu m)$
Greek sv	mbols
α	contact thermal accommodation parameter
в	gas property parameter
v	mobility $(m^3 s/kg)$
ż	shear rate
2	interface thickness parameter (m)
2	factor accounting for the gaps between the circles
č	surface tension of polymer melt (N/m)
s no	zero shear viscosity (Pa s)
nain	dynamic viscosity of air (Pa s)
n	dynamic viscosity of polymer melt (Pa s)
·γpm λ	mixing energy density (N)
Λ	gas mean free nath (um)
11	dynamic viscosity of cooling water (Pa s)
$\rho_{cw}$	density of air $(kg/m^3)$
Pair	density of cooling water $(kg/m^3)$
pcw 0	density of polymer melt $(kg/m^3)$
$\rho_{pm}$	standard deviation of the asperities heights on the front
0	of stamper (um)
G	standard deviation of the asperities heights on the core
0 <sub>core</sub>	standard deviation of the aspenties heights on the core
~	(µIII) offoctive PMS surface roughposs (µm)
0 <sub>e</sub>	effective Rivis sufface foughtiless (µiii)
$\sigma_s$	standard deviation of the asperities neights on the back
_ *k	of stamper (µm)
$ au^*$	critical stress level at the transition to shear thinning
,	(Pa)
$\psi$	phase field help variable
Φ	phase field variable
Subscripts	
CC	cooling channel
(-(	between cooling water and core
CW	cooling water
ρ	effective
с f1	fluid 1 (nolymer melt)
ப	fluid 2 (polymer men)
17	

- fluid 2 (air) injection f2 inj т mean mi microscale inlet
- polymer melt рт between polymer and stamper

p-s

- stamper S
- between stamper and core surface tension S−C st

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